

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/789,400	COLLINS ET AL.	
	Examiner	Art Unit	
	Shin-Lin Chen	1632	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
424	93.2	11/20/2009	SLC
424	199.1		
	211.1	11/20/2009	SLC
Sequence interference search		11/20/2009	SLC